

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:. Wu et al.

Attorney Docket No.: NOVLP097/NVLS-

2906

Application No.: 10/807,680

Examiner: Not yet assigned

Filed: March 23, 2004

Group: 2812

Title: METHODS OF POROGEN REMOVAL

FOR POROUS LOW DIELECTRIC CONSTANT FILMS USING PLASMA

**TREATMENTS** 

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on October 17, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Tara Hayden

INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP097).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

P.O. Box 70250 Oakland, CA 94612-0250 Jeffrey K. Weaver Registration No. 31,314 OCT 19 2005 W

1449 (Modified)

Atty Docket No. NOVLP097/ NVLS-2906 Application No.: 10/807,680

Information Disclosure Statement By Applicant Applicant: Wu et al.

(Use Several Sheets if Necessary)

Filing Date March 23, 2004 Group 2812

**U.S. Patent Documents** 

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Foreign Patent or Published Foreign Patent Application

	Document	Publication	Country or		Sub-	Trans	lation
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## **Other Documents**

Examiner		
Initial	Author, Title, Date, Place (e.g. Journal) of Publication	
	C1	U.S. Office Action mailed August 24, 2005, from U.S Application No. 10/404,693
		[Atty Dkt No. NOVLP064/NVLS-794].
	C2	U.S. Office Action mailed September 1, 2005, from U.S Application No. 10/672,305
		[Atty Dkt No. NOVLP069/NVLS-000821].
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Examiner	_l	Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.